

Attorney Docket No. Serial No. 041514-5211 10/043,260 INFORMATION DISCLOSURE CITATION Applicant (Use several sheets if necessary) Hiroaki KITAHARA et al. **PTO Form 1449** Filing Date Group January 14, 2002 2881 **U.S. PATENT DOCUMENTS** *Examiner Document Sub Initial Number Date Name Class Class Filing Date 4.334,778 Jun. 15, 1982 Pardue et al. 356 349 Sep. 12, 1980 SAT Jun. 15, 1993 356 357 Dec. 20, 1991 5,220,405 Barbee et al. 5A T 5A T 5,579,109 Nov. 26, 1996 Suh et al. 356 349 Sep. 9, 1994 FOREIGN PATENT DOCUMENTS Document Sub Translati n Number Date Country Class Class YES NO OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) Kloos, G., "Design of a Michelson interferometer for the measurement of electrostrictive SAT strains," Optics & Laser Technology, Vol. 28, No. 6, Sept. 1, 1996, pp. 481-484 Examiner Date Considered 4-2-04 Initial if reference considered, whether or not citation is in conformance with MPEP 609£ draw line Examiner: through citation if not in conformance and not considered. Include copy of this form with Fnext communication to applicant.